Docket No.: 51876P558

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

JOON-YUL YUN

Application No.:

Filed:

For: Method for Sensing Bit Line with

Uniform Sensing Margin Time and

Memory Device Thereof

Art Group:

Examiner:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure, enclosed is a copy of Information Disclosure Statement by Applicant (form PTO/SB/08), which is being submitted. It is respectfully requested that the cited references be considered and that the enclosed copy of PTO/SB/08 be initialed by the Examiner to indicate such consideration and a copy thereof returned to applicant(s). Copies of the references cited on PTO/SB/08 are enclosed herewith.

The submission of this Information Disclosure Statement is not to be construed as a representation that a search has been made in the subject application and is not to be construed as an admission that the information cited in this statement is material to patentability.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

William Thomas Babbitt, Reg. No. 39,591

12400 Wilshire Boulevard, 7th Floor Los Angeles, CA 90025 Telephone: (310) 207-3800

Date: 12/31/03

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Complete if Known Substitute for form 1449A/PTO Application Number INFORMATION DISCLOSURE Filing Date First Named Inventor Joon-Yul Yun STATEMENT BY APPLICANT Art Unit (use as many sheets as necessary) **Examiner Name** 1 Sheet 1 of Attorney Docket Number

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U.S. PATENT DOCUMENTS									
Examiner Initials*	Cite No. ¹	Document Number Number - Kind Code ² (if known)	Publication Date or Issue Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear				
		US-6,009,040	12-28-1999	Choi et al.					
		US-6,038,180	03-14-2000	Hoshi					
		US-5,892,722	04-06-1999	Jang et al.					
		US-5,610,868	03-11-1997	Inaba et al.					
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FOREIGN PATENT DOCUMENTS									
Examiner Initials*	Cite	Foreign Patent Document			Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Т°			
	No.1	Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document					
		JP 11-039899	02-12-1999	NEC Corp.					
		JP 09-180472	07-11-1997	Samsung Electron Co. Ltd.					
		JP 05-013709	01-22-1993	Matsushita Electric Ind. Co.					
		JP 04-192182	07-10-1992	Mitsubishi Electric Corp.					
		JP 03-016082	01-24-1991	Toshiba Corp.					
		JP 01-173390	07-10-1989	Toshiba Corp.					
		JP 02-189791	07-25-1990	NEC IC Microcomput Syst.	-				
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Examiner	Date	
Signature	Considered	
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^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.